

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Eiichi ISHII et al. :
Serial No. NEW : **Attn: APPLICATION BRANCH**
Filed September 11, 2003 : Attorney Docket No. 2003-1290

METHOD OF SURFACE TREATMENT
OF TITANIUM METAL

(Rule 1.53(b) Continuation-in-Part of
Serial No. 09/902,260, Filed July 11, 2001)

CLAIM OF PRIORITY UNDER 35 U.S.C. § 119

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 2000-211518, filed July 12, 2000, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Application is of record in parent application Serial No. 09/902,260, filed July 11, 2001.

Respectfully submitted,

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